



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q64809

Kenji Matsumoto

Appln. No.: 09/873,218

Group Art Unit: 2828

Confirmation No.: 4028

Examiner: Tuan M. NGUYEN

Filed: June 5, 2001

For: SEMICONDUCTOR LASOR FABRICATING METHOD OF THE SAME

RESPONSE UNDER 37 C.F.R. § 1.111

MAIL STOP NON-FEE AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated February 27, 2003, please consider the following remarks:

REMARKS

As a preliminary matter, the Examiner has not acknowledged the drawing corrections submitted on December 10, 2002, with the Amendment to the September 11, 2002 Office Action. Accordingly, Applicant respectfully requests the Examiner to acknowledge the drawing corrections in the next Action.

Turning to the art rejections, claims 1-5 have been rejected under 35 U.S.C. § 102(b) as being anticipated by U.S. Patent 5,294,564 to Karapiperis et al. ("Karapiperis").

Applicant submits that claim 1 is patentable over the cited reference. For example, claim 1 recites the formation of a plurality of layers in parallel with an activation layer. Claim 1

8/11/Response
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